

<b>Notice of References Cited</b>	Application/Control No. 09/580,454	Applicant(s)/Patent Under Reexamination ONO ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0205598	10-2004	Takahashi et al.	715/513
	B	US-2002/0065814	05-2002	Okamoto et al.	707/3
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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